

**Amendments to the Specification:**

*Please replace paragraph [0006] with the following amended paragraph:*

A lower dielectric layer 22 and a barrier rib 24 are formed on the lower substrate 18 in which the address electrode X is formed, and a phosphor layer 26 is coated on surfaces of the lower dielectric layer 22 and the barrier rib 24. The address electrode X is formed in a crossing direction of the scan electrode Y and the sustain electrode Z. The barrier rib 24 is formed in a stripe or grid shape to prevent an ultraviolet ray and a visible ray, created by the discharge, from being leaked into adjacent discharge cells. The phosphor layer 26 is excited by the ultraviolet ray in the plasma discharge to generate any one of visible rays of red, green and blue. The mixed inert gas is injected into a discharge space provided between the upper/lower substrates 10 and 18 and the barrier rib 24.

*Please replace paragraphs [0037] and [0038] with the following amended paragraphs:*

[0037] FIG. 9 is a view of a protrusion formed at a filter support shown in FIG. 8; and

[0038] FIG. 10 is a sectional view illustrating a fixing procedure of a filter support, a film type front surface filter and a support member according to second embodiment of the present invention; and FIG. 11 is a sectional view of a plasma display panel with a back cover according to an embodiment of the present invention.

*Please replace paragraph [0041] with the following amended paragraph:*

Referring to FIG. 7, the PDP according to a first embodiment of the present invention includes a panel 72 formed by adhering the upper substrate to the lower substrate and a film type front surface filter 70 disposed at a front surface of the panel 72. A heat sink (not shown), a printed circuit board (not shown) and a back cover ~~(not shown) 38~~ (shown in Fig. 11) formed to

encompass a rear surface of the PDP are disposed at a rear surface of the panel 72. Further, the PDP according to the first embodiment of the present invention includes a filter support 74 for electrically connecting the film type front surface filter 70 with the back cover, and a support member 76 disposed between the film type front surface filter 70 and the back cover 38 to encompass the filter support 74.

***Please replace paragraph [0052] with the following amended paragraph:***

On the other hand, in the second embodiment of the present invention, as shown in FIG. 9, at a surface having the metallic layer 82 and the filter support 84 connected to each other, that is, at an end of the filter support 84 is formed a plurality of protrusions 90 such that a contact resistance can be reduced between the metallic layer 82 and the filter support 84. Additionally, in the present invention, as shown in FIG. 10, the support member 86, the metallic layer 82 and the filter support 84 can be fixed using at least one screw 92 for passing through the support member 86, the metallic layer 82 and the filter support 84. Herein, the support member 86, the metallic layer 82 and the filter support 84 respectively have at least one hole (not shown) for allowing insertion of the screw 92. Finally, FIG. 11 shows an embodiment of the present invention with a back cover 38 spaced from and disposed in a backward position of the panel. The structure of the back cover 38 is similar to that shown in FIG. 3. The magnified view is that of FIG. 7.